

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	57715	nitride and wafer	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 16:16
L2	476	nitride adj wafer	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 16:17
L3	118	I2 and polish\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 16:42
L4	88	I2 and ultraviolet	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 16:49
L5	921	potassium adj peroxodisulfate	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 16:50
L6	121	I5 and ultraviolet	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 16:50
L7	11	I6 and (CMP or polish\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 16:58
L8	1	I2 and I5	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 16:59
L9	6	I1 and I5	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 17:21
L10	2061611	wafer or substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 17:21
L11	4337	peroxodisulfate or peroxydisulfate	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 17:22
L12	1869	I11 near2 potassium	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 17:23

L13	608	10 and 12	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 17:24
L14	138	13 and ultraviolet	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2004/11/30 17:24